Column 1	Column 2	Column 3	Column 4	Column 5
Tariff Item Number	Description of Goods	Base Rate	Category	Note
	- - - Of spraying appliances for etching, stripping or cleaning semiconductor wafers; of apparatus for wet etching, developing, stripping or cleaning semiconductor wafers; of dry-etching patterns on semiconductor materials:			
8486.90.24.00.00	- - - - Tool holders and self-opening dieheads; work holders; dividing heads and other special attachments for machine tools		A	
8486.90.25.00.00	- - - - Other		A	
	- - - Of dicing machines for scribing or scoring semiconductor wafers; of lasercutters for cutting tracks in semiconductor production by laser beam; of machines for bending, folding and straightening semiconductor leads:			
8486.90.26.00.00	- - - - Tool holders and self-opening dieheads; workholders; dividing heads and other special attachments for machine tools		A	
8486.90.27.00.00	- - - - Other		A	
8486.90.28.00.00	- - - Of resistance heated furnaces and ovens for the manufacture of semiconductor devices on semiconductor wafers; of inductance or dielectric furnaces and ovens for the manufacture of semiconductor devices on semiconductor wafers		A	
8486.90.29.00.00	- - - Other		A	
	- - Of machines and apparatus for the manufacture of flat panel displays:			
8486.90.31.00.00	- - - Of apparatus for dry etching patterns on flat panel display substrates		A	
	- - - Of apparatus for wet etching, developing, stripping or cleaning flat panel displays:			
8486.90.32.00.00	- - - - Tool holders and self-opening dieheads; work holders; dividing heads and other special attachments for machine tools		A	
8486.90.33.00.00	- - - - Other		A	
8486.90.34.00.00	- - - Of chemical vapor deposition apparatus for flat panel display production		A	
8486.90.35.00.00	- - - Of spinners for coating photosensitive emulsions on flat panel display substrates		A	
8486.90.36.00.00	- - - Of apparatus for physical deposition on flat panel display substrates		A	
8486.90.39.00.00	- - - Other		A	
	- - Of machines or apparatus specified in Note 9 (C) to this Chapter:			
8486.90.41.00.00	- - - Of focused ion beam milling machine to produce or repair masks and reticles for patterns on semiconductor devices		A	
8486.90.42.00.00	- - - Of die attach apparatus, tape automated bonders, wire bonders and of encapsulation equipment for assembly of semiconductors		A	
8486.90.43.00.00	- - - Of automated machines for transport, handling and storage of semiconductor wafers, wafer cassettes, wafer boxes and other materials for semiconductor devices		A	
8486.90.44.00.00	- - - Of optical stereoscopic and photomicrographic microscopes fitted with equipment specifically designed for the handling and transport of semiconductor wafers or reticles		A	
8486.90.45.00.00	- - - Of electron beam microscopes fitted with equipment specifically designed for the handling and transport of semiconductor wafers or reticles		A	
8486.90.46.00.00	- - - Of pattern generating apparatus of a kind used for producing masks or reticles from photoresist coated substrates, including printed circuit assemblies		A	
8486.90.49.00.00	- - - Other		A	
84.87	Machinery parts, not containing electrical connectors, insulators, coils, contacts or other electrical features, not specified or included elsewhere in this Chapter.			
8487.10.00.00.00	- Ships' or boats' propellers and blades therefor		A	
8487.90.00.00.00	- Other		A	
Chapter 85	Electrical machinery and equipment and parts thereof; sound recorders and reproducers, television image and sound recorders and reproducers, and parts and accessories of such articles			
85.01	Electric motors and generators (excluding generating sets).			